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PATENT  
Docket No. 150.00810102IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Brian A. Vaartstra ) Group Art Unit: 2823  
Serial No.: 09/865,612 ) Examiner: George Fourson III  
Confirmation No.: 4697 )  
Filed: May 25, 2001 )  
For: METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-  
CONTAINING FILMS ON SEMICONDUCTOR STRUCTURES

FACSIMILE TRANSMISSION TO THE PTO

Assistant Commissioner for Patents  
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Name: SARA E. OLSON

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Dear Sir:

In response to the Office Action mailed August 20, 2003, please amend the  
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on the page  
entitled "Amendments to the Claims."

Remarks begin on the page entitled "Remarks."